

APPLICATION TRANSFER REQUEST FOR

10/040,272

Section I. TRANSFER REQUEST BY (PRINT NAME) Q. Leung Date: 7/30/02

TO: AU 3742 Class 219/686+ FROM: AU 2828, Class 372

REASON:

System and process for heating semiconductor wafers. Note related US patents 4622447, 4517026 and 5219798.

Gatekeeper concurrence _____

Hand carried: Personally accepted by _____

Section II a. DISPOSITION BY RECEIVING TC By: J Walberg A.U. 3742 Date 8/1/02

☒ **ACCEPTED BY RECEIVING T.C.**

NOT ACCEPTED

☐ Non-classification issue/other, return to Originating TC/AU _____

REASON:

Section II b. DISPOSITION BY RECEIVING TC POST CLASSIFIER

☐ This dispute was resolved. Forward to _____

Concurring _____ Date _____

☐ This dispute was not resolved, forward to DISPUTE RESOLUTION PANEL

Post Classifier Assessment:

Gatekeeper Concurrence _____

Post Classifier _____

Section III. DISPOSITION BY DISPUTE RESOLUTION PANEL

Date _____

Panel Decision:

REASON:

Panel Member _____ Concurring Panel Member _____

☐ This application **MAY NOT** be returned to the dispute resolution panel. **THIS IS A FINAL DISPOSITION.**